



Form 1449 (Modified)		Atty Docket No. MODEP001
Information Disclosure Statement By Applicant		Application No.: 10/665,980
		Inventor MIDDLEBROOKS, et al
		Group unassigned 2128
		Filing Date September 19, 2003
(Use Several Sheets if Necessary)		

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
A							
B							
C							
D							
E							
F							
G							
H							
I							
J							
K							

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
L								
M								
N								
O								
P								

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication	
ZF	R	Middlebrooks, Scott A., "Optimal Model-Predictive Control of Overlay Lithography Implemented in an ASIC Fab" Proceedings of SPIE, Microlithography 2003, 5044-2	
ZF	S	Muske, Kenneth Robert, "Linear Model Predictive Control of Chemical Processes" University of Texas at Austin, May 1995.	
	T		

Examiner Date Considered

Russell Frejd

30-Sep-05

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.